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CONFIRMATION NO. 4877

SERIAL NUMBER	FILING or 371(c) DATE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.		
10/586,445	07/17/2006	117	1792	1110/97825		
RULE						
APPLICANTS Kozo Nakamura, Kanagawa, JAPAN; Junsuke Tomioka, Kanagawa, JAPAN; Tetsuro Akagi, Kanagawa, JAPAN; Shiro Yoshino, Kanagawa, JAPAN; ** CONTINUING DATA ***** This application is a 371 of PCT/JP05/01114 01/27/2005 ** FOREIGN APPLICATIONS ***** JAPAN 2004-018313 01/27/2004 ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 05/05/2009						
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and Acknowledged <u>/BOB M KUNEMUND/</u> Examiner's Signature		<input type="checkbox"/> Met after Allowance Initials	STATE OR COUNTRY	SHEETS DRAWINGS	TOTAL CLAIMS	INDEPENDENT CLAIMS
			JAPAN	6	5	4
ADDRESS Husch Blackwell Sanders, LLP Husch Blackwell Sanders LLP Welsh & Katz 120 S RIVERSIDE PLAZA 22ND FLOOR CHICAGO, IL 60606 UNITED STATES						
TITLE Method for predicting precipitation behavior of oxygen in silicon single crystal, method for determining production parameter of silicon single crystal, and storage medium for storing program for predicting precipitation behavior of oxygen in silicon single crystal						
FILING FEE RECEIVED 1100	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:			<input type="checkbox"/> All Fees		
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